Notic of Allowability	Application No.	Applicant(s)
	10/689,386	BOJKOV ET AL.
	Examiner	Art Unit
	Nitin Parekh	2811
The MAILING DATE of this communication appear. All claims being allowable, PROSECUTION ON THE MERITS IS (Continuous theorem), a Notice of Allowance (PTOL-85) of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOR of the Office or upon petition by the applicant. See 37 CFR 1.313 and the office of the Offi	OR REMAINS) CLOSED in this appropriate communication HTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to <u>07-20-05</u> .		
2. The allowed claim(s) is/are <u>1-22</u> .		
 3. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the: 1. Certified copies of the priority documents have be compared as a copies of the priority documents have be copies of the certified copies of the priority documents have be copies of the certified copies of the priority documents have be copies of the certified copies of the priority documents have be copies of the certified copies of the priority documents have be copies of the certified copies of the priority documents have be copied. * Certified copies not received: 	een received. een received in Application No ments have been received in this i	national stage application from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONME THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be submitted.	NT of this application.	
INFORMAL PATENT APPLICATION (PTO-152) which gives	reason(s) why the oath or declara	tion is deficient.
5. CORRECTED DRAWINGS (as "replacement sheets") must be	pe submitted.	
(a) ☐ including changes required by the Notice of Draftspersor	n's Patent Drawing Review (PTO-	948) attached
1) hereto or 2) to Paper No./Mail Date		
(b) including changes required by the attached Examiner's A Paper No./Mail Date	Amendment / Comment or in the O	office action of
Identifying indicia such as the application number (see 37 CFR 1.84 each sheet. Replacement sheet(s) should be labeled as such in the		
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT FO		
Attachment(s) 1. Notice of References Cited (PTO-892)	5. Notice of Informal Page	atent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08)	Paper No./Mail Dat , 7. ⊠ Examiner's Amendm	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ☑ Examiner's Stateme 9. ☐ Other	Nitin Parekh Primary Examiner

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DETAILED ACTION

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Allowable Subject Matter

1. Claims 1-22 are allowed.

Examiner's Amendment

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

A. Claim 4, line 3: Delete "polyimide"

B Claim 17, line 1: Delete "t" and Insert --- "to" ---.

Authorization for this examiner's amendment was given in a telephone interview with Yingsheng Tung on 09-02-05.

Reasons for Allowance

3. The following is an examiner's statement of reasons for allowance:

The references of record do not teach either singularly or in combination at least the limitations "a stack of protection layers over the surface of said chip, said stack comprising a first inorganic layer on said surface, a polymer layer on said first inorganic layer, and a second inorganic layer on said polymer layer" and "a patterned seed metal

layer on said metallization in said window and on said second inorganic layer around said window, and buffer metal layer positioned on said seed metal layer" in a semiconductor device including a contact pad, circuit metallization and a window in a stack of protection layers exposing the metallization on the surface of an integrated circuit chip.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Nitin Parekh whose telephone number is 571-272-1663. The examiner can normally be reached on 09:00AM-05:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's acting supervisor, Steven Loke can be reached on 571-272-1657. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAN or Public PAG. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAG system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

NP

NITIN PAREKH

Nitrifareth

09-02-05

PRIMARY EXAMINER

TECHNOLOGY CENTER 2800